Nov. 2, 2019 14:00-14:35

Asia Communications and Photonics Conference: PR Workshop on Microcavity Photonics Talk 6

Broad bandwidth phase-matched four-wave mixing in dispersion-engineered microresonators

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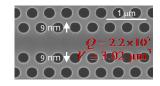
2. Department of System Design Engineering,

Faculty of Science and Technology, Keio University

Projects in my group

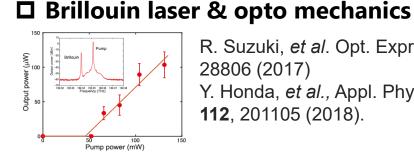


High-Q PhC nanoresonator



Y. Ooka, et al., Sci. Rep. 5, 11312 (2015).

□ Si PhC photo receiver/modulator

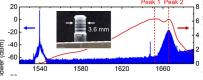


R. Suzuki, et al. Opt. Express 25, 28806 (2017) Y. Honda, et al., Appl. Phys. Lett. **112**, 201105 (2018).

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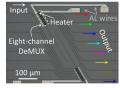
N. Daud, et al., AIP Adv. 8, 105224 (2018). Y. Ooka, et al., Opt. Express, 24, 11199 (2016).

Raman comb & Er doped + CNT toroid



R. Suzuki, et al., J. Opt. Soc. Amer. B 35, 933 (2018). T. Kumagai, et al. J. Appl. Phys. 123, 233104 (2018).

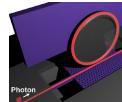
Si PhC WDM filter & other



Y. Ooka, et al. Opt. Express **25**, 1521 (2017).

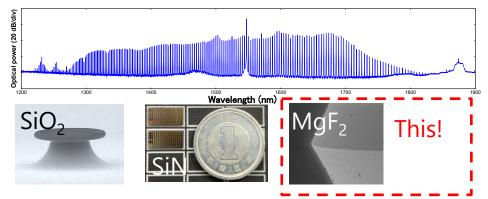


Coupling WGM w/ PhC



Y. Zhang, et al., Opt. Lett (2019) in press.

FWM & microresonator frequency comb



S. Fujii, et al., J. Opt. Soc. Amer. B 35, 100 (2018). S. Fujii, et al., Opt. Lett. 44, 3146 (2019).

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Acknowledgement



Design & measurement



Shun Fujii



Koshiro Wada

Ultra-precision fabrication



Yuka Hayama

Prof. Yasuhiro Kakinuma



- 1. Background and motivation
- 2. Dispersion engineering of MgF₂ microresonators
- 3. Fabrication by computer-controlled turning
- 4. Phase-matched four-wave mixing (μ-comb generation)
- 5. Conclusion



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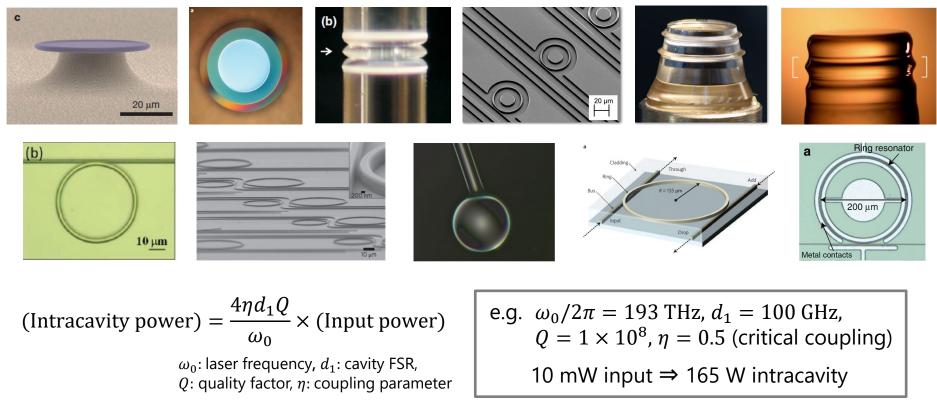




Whispering gallery mode (WGM) optical microresonator

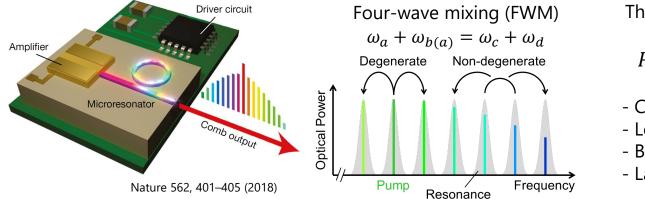
Confines light for long photon lifetime (high Q) and has small volume Enhances light-matter interaction in dielectric material

Dielectric microresonator platforms (Caltech, NIST, EPFL, OEwaves, Columbia, Harvard, Yale, INRS-EMT)

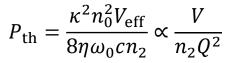




Target application: Microresonator frequency comb (Kerr comb)

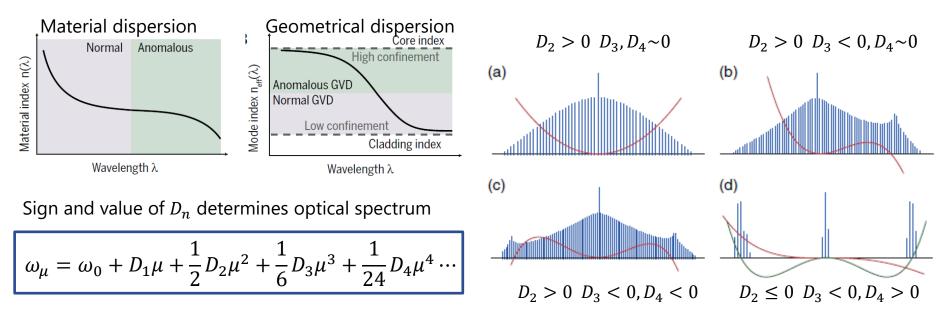


Threshold power for FWM



- Compact size
- Low energy consumption
- Broad bandwidth
- Large mode spacing ~1000 GHz

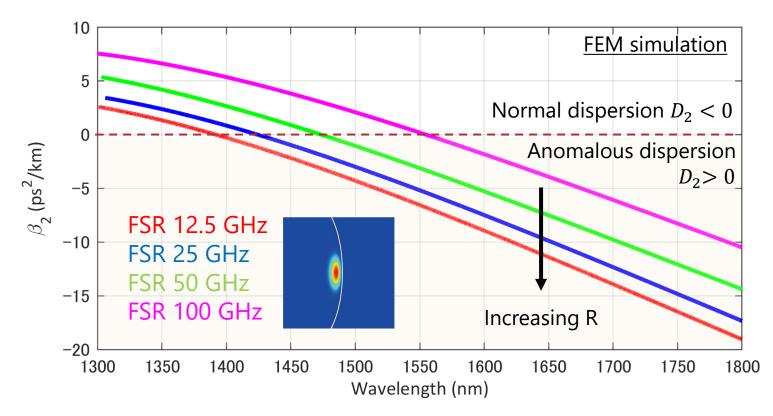
Microresonator dispersion and the effect on microcomb spectrum



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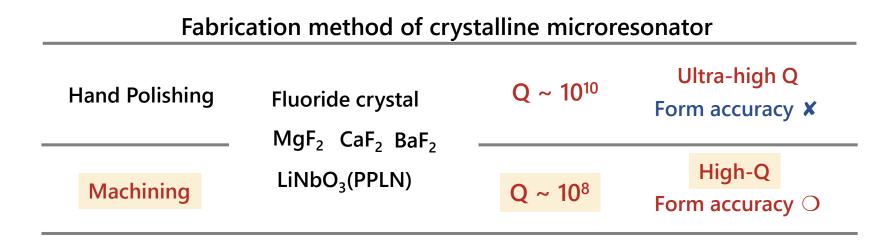


GVD parameters β_2 for MgF_2 microresonators with different FSRs



- 100 GHz FSR microresonator shows weak normal dispersion in 1550 nm band
- Geometrical dispersion limits microcomb generation in small-R MgF₂ resonator





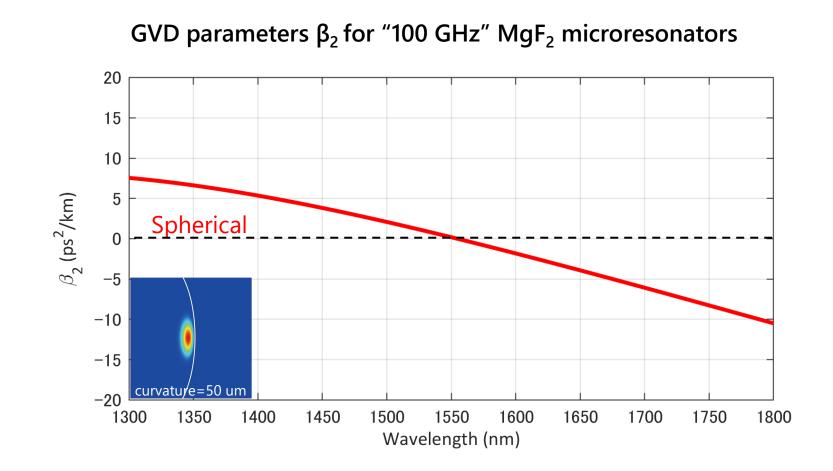
- Fabricate ultra-high Q crystalline microresonators (Q>10⁸) by computer-controlled machining without polishing process
- Explore resonator cross-section which realizes anomalous dispersion for 100 GHz free-spectral range (FSR) crystalline microresonators

Overcome Q limitation to achieve 100 GHz FSR microcomb generation

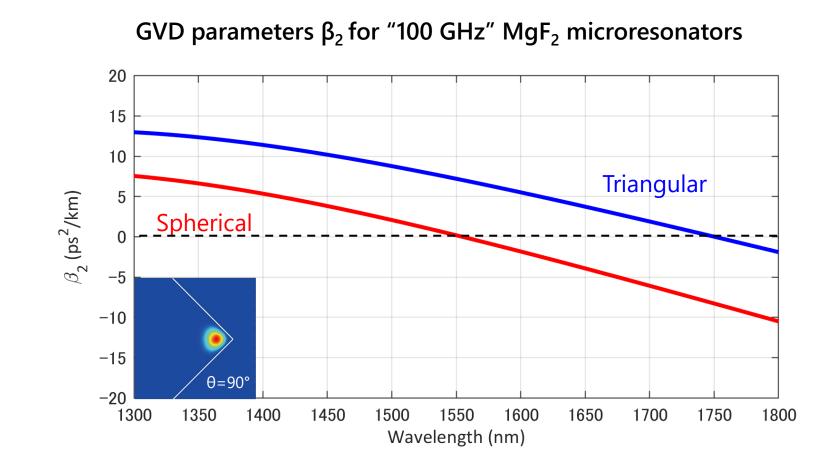


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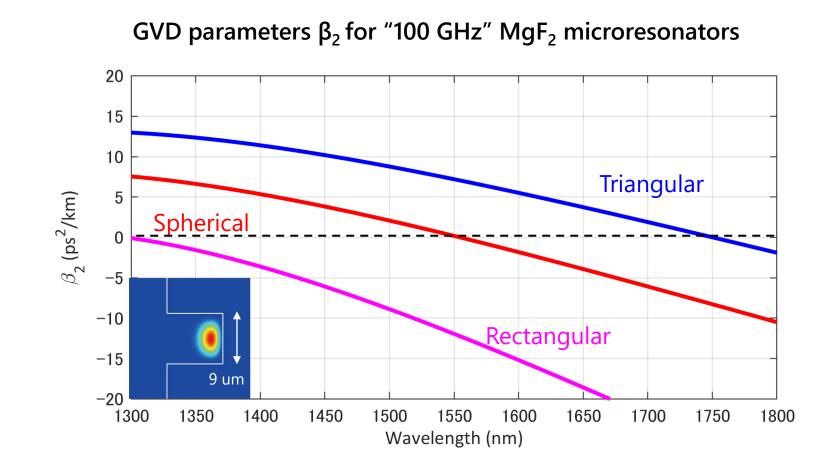






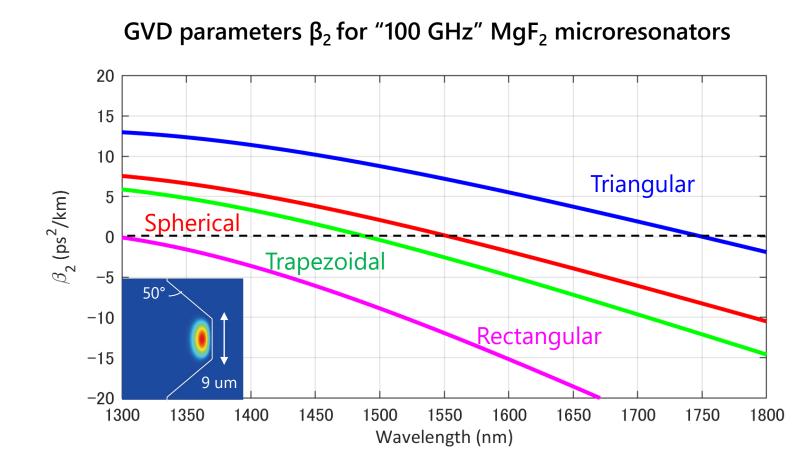






14 Dispersion control in high-Q resonator





- Degree of freedom of structures allows us to control resonator dispersion
- Rectangular shape is ideal for realizing anomalous group-velocity dispersion

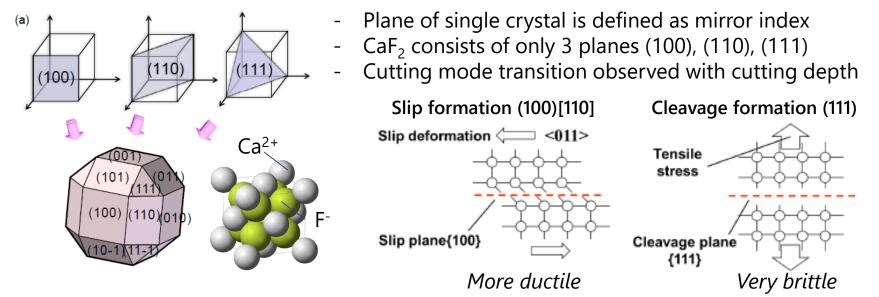


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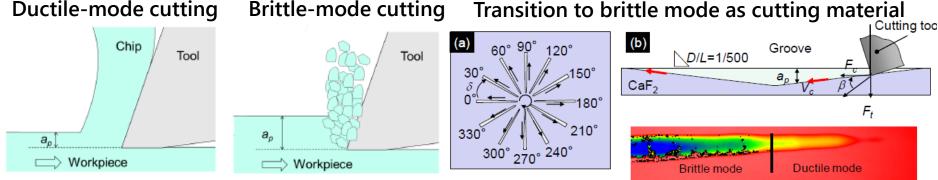


Crystallographic image of CaF₂ material

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Cutting mode transition is observed depending on crystal anisotropy

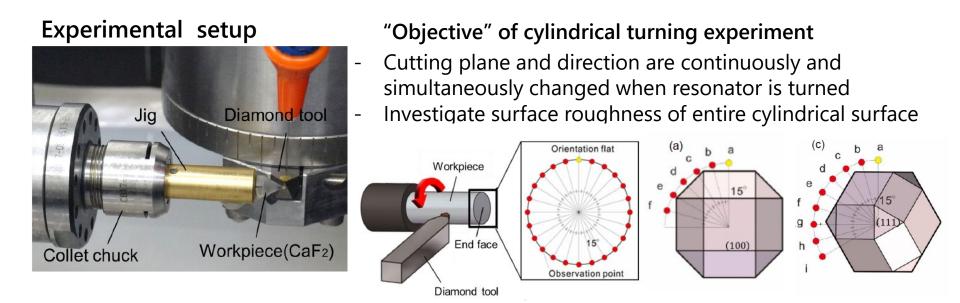


Cutting depth < Critical depth Cutting depth > Critical depth

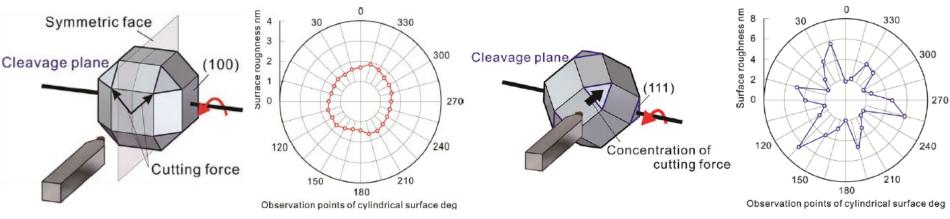
Precision Engineering 40 (2015) 172-181

Cylindrical turning experiment





Cylindrical surface roughness for observation points with different end-faces

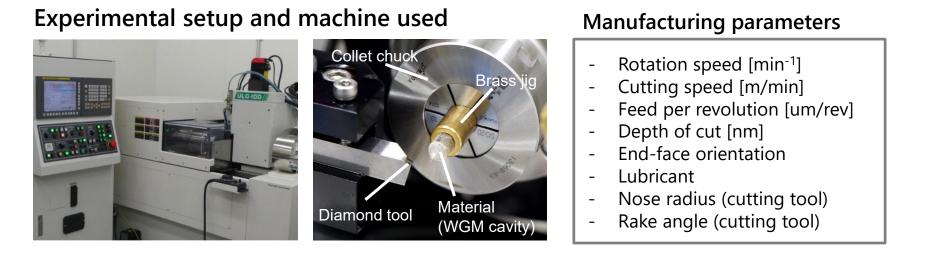


Observed smooth surface with end-face (100)

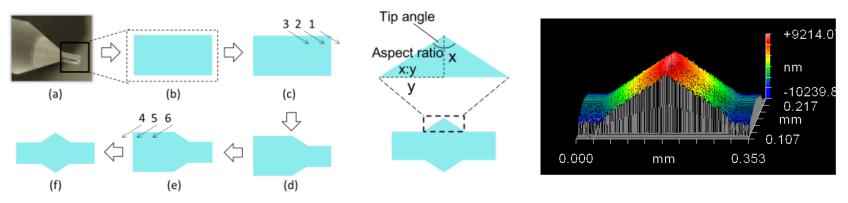
Observed surface clack with the end-face (111)

Precision Engineering 40 (2015) 172–181 Precision Engineering 49 (2017) 104–114



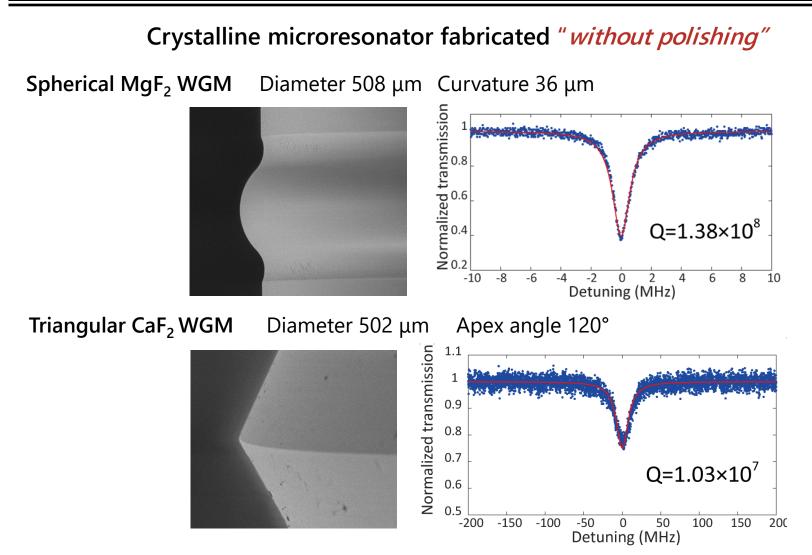


Fabrication flow of ultra-precision turning for triangular cross-section microresonator



The tip angle and the aspect ratio are pre-designed and formed by computer-controlled turning, which is attractive with respect to dispersion engineering





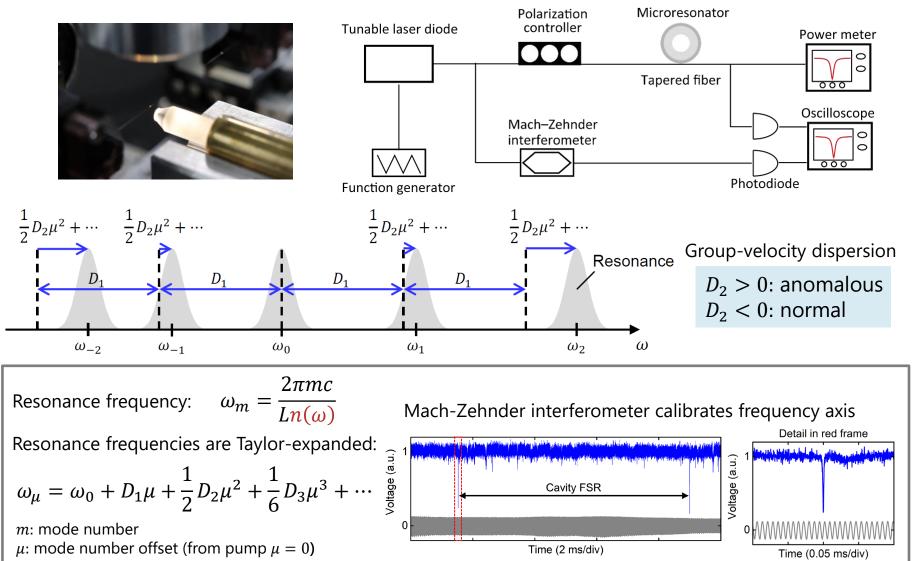
- High-Q of >10⁸ was obtained in MgF₂ spherical WGM resonator
- Effect of crystal anisotropy is investigated and we cut at an optimized end-face direction
- MgF₂ is more suitable for Kerr comb generation as regards thermal stability



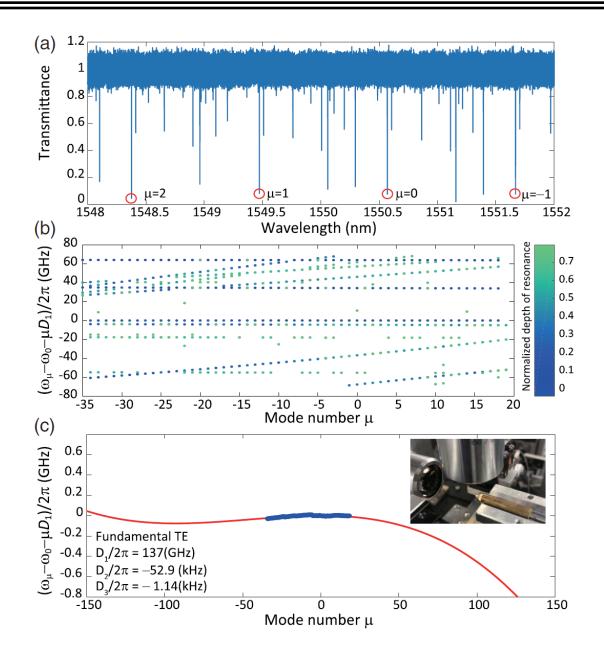
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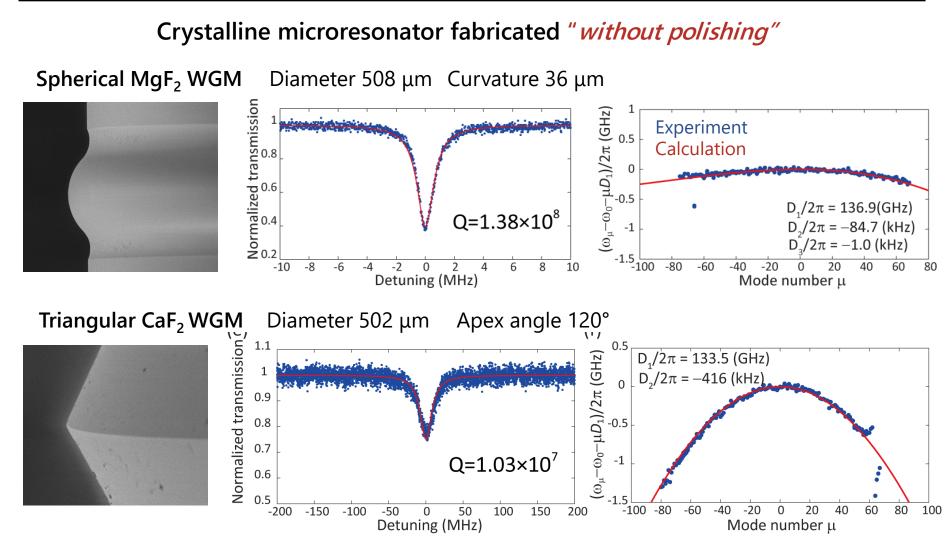
Experimental setup for Q-factor and dispersion measurement











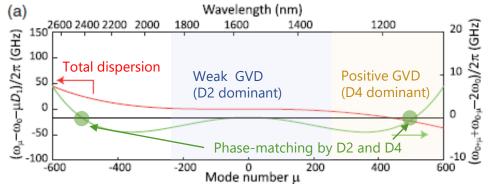
- High-Q of > 10⁸ was obtained in MgF₂ spherical WGM resonator
- Designed dispersion is obtained

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24 Octave-wide phase-matched FWM



- Principle: Negative GVD (D2<0) is compensated by positive D4 far from the pump mode



Phase-matching condition (PMC) for initial sidebands μ $\Delta \omega = \omega_{\mu} - \omega_{0} - (\omega_{0} - \omega_{-\mu}) = D_{2}\mu^{2} + \frac{D_{4}}{12}\mu^{4} \rightarrow 0$ $\mu^{2} = -\frac{12D_{2}}{D_{4}} (D_{2} \cdot D_{4} < 0)$

Negative D_2 and Positive D_4 satisfy PMC far from the pump Strong negative D_2 enables large frequency shift

- Numerical simulation (LLE)

LLE (Lugiato-Lefever equation) w/ all order dispesion

$$\frac{\partial A(\phi,t)}{\partial t} = -\left(\frac{\kappa_{tot}}{2} + i\delta_0\right)A + i\sum_{k=2}\frac{D_k}{k!}\left(\frac{\partial}{i\partial\phi}\right)^kA + ig|A|^2A + \sqrt{\kappa_{ext}}A_{in}$$

 κ_{tot} : loaded decay rate ($Q_{tot} = \omega_0 / \kappa_{tot}$)

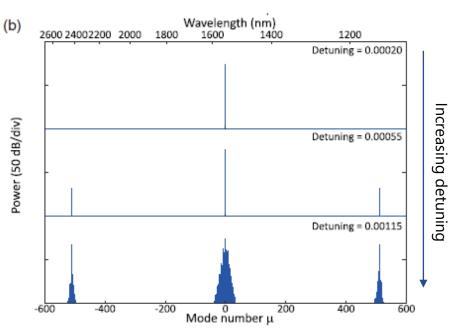
- κ_{ext} : coupling rate ($Q_{ext} = \omega_0 / \kappa_{ext}$)
- δ_0 : pump detuning

$$D_k$$
: k-order dispersion ($k \ge 2$)

g : nonlinear coefficient

 A_{in} : input field (pump)

- FWM sidebands spanning one-octave via higher-order dispersion (4th order dispersion)

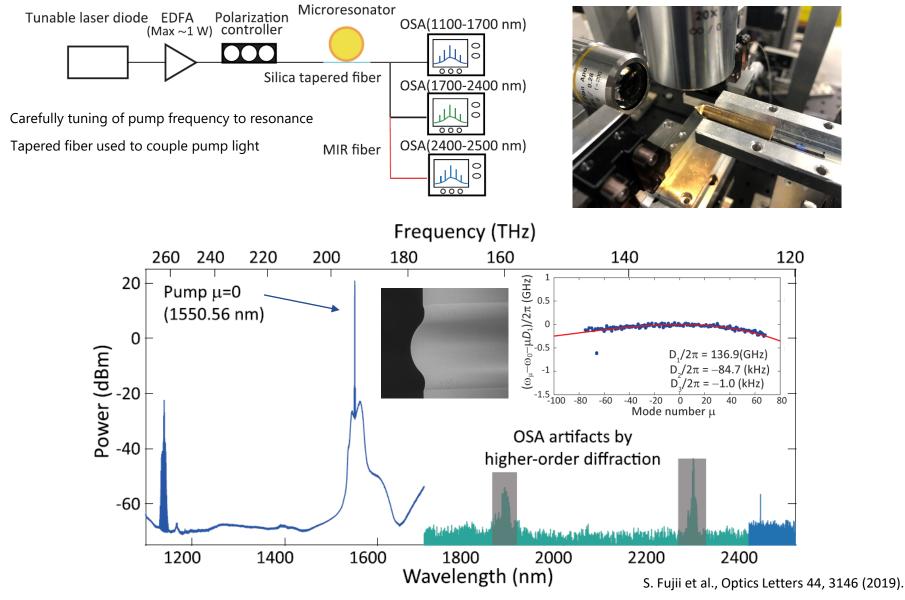


Octave-wide phase-matched FWM



- Experiment

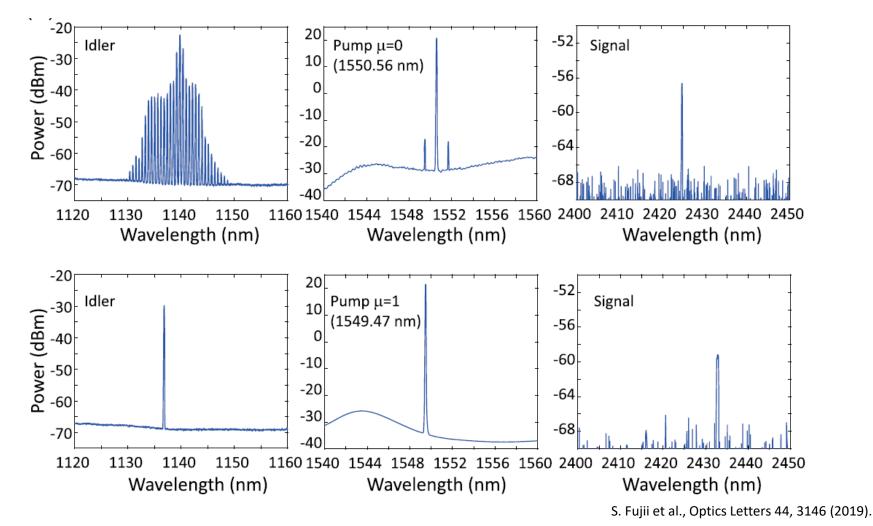
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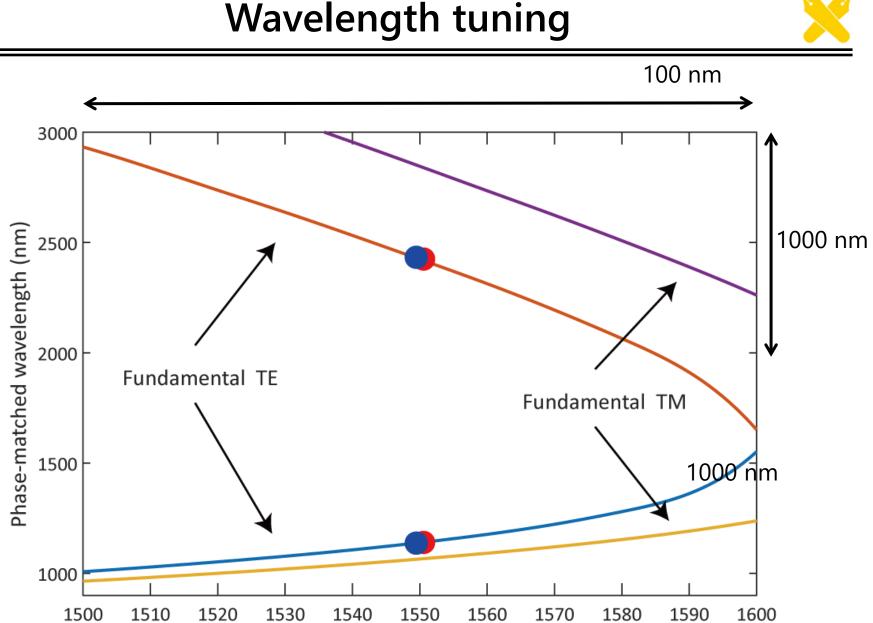
26 Octave-wide phase-matched FWM

×

- Experiment



 Shorter wavelength pump allows us to obtain larger frequency shift by the balance between D2 and D4 (Tunability of oscillation wavelegnths)



Pump wavelength (nm)



- Proposed ideal WGM structure for 100-GHz FSR microcomb in MgF_2 crystalline microresonators (rectangular shapes achieve anomalous dispersion in 1550 nm)
- Identified critical depth and for each end-face orientation to acheive ultraprecision machining of crystalline microresonators
- Observed highest Q exceeding 10⁸ and microcomb without polishing process
- Demonstrated octave-wide FWM in dispersion-engineered microresonators

Thank you

Publication

S. Fujii et al., "Octave-wide phase-matched four-wave mixing in dispersion engineered crystalline microresonators", Optics Letters **44**, 3146 (2019).

<u>Acknowledgment</u>

This work is supported by Japan Society for the Promotion of Science (JSPS) KAKENHI under Grant Number JP19H00873, and SCOPE 191603001 from MIC.

We thank Dr. Y. Mizumoto, H. Kangawa for their contribution of this work